

METHOD FOR GROWING THIN OXIDE FILMS

RITALA et al.

Appl. No.: Herewith      Atty Docket: SEPP5.001C1

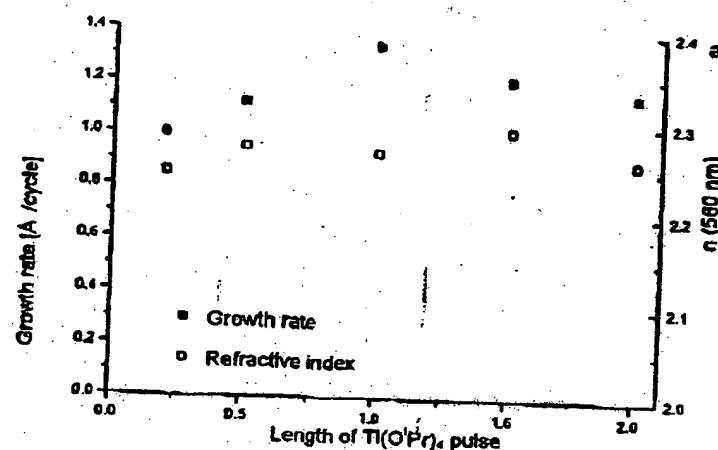


Fig. 1

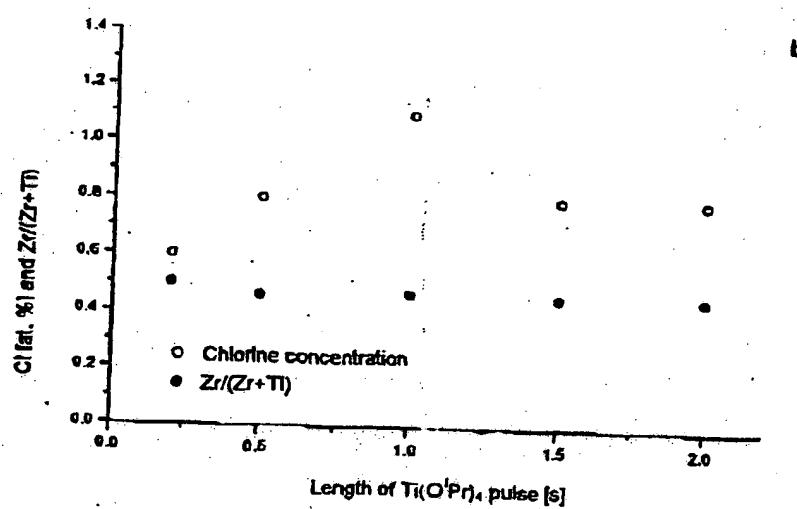


Fig. 2